

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA, Naomasa SHIRAISHI and Soichi OWA

Application No.: NEW US PATENT APPLICATION

Filed: January 26, 2001

Docket No.: 108455

For: PROJECTION EXPOSURE APPARATUS AND METHOD, REFLECTIVE/REFRACTIVE
OPTICAL SYSTEM, AND METHOD OF MANUFACTURING A DEVICE#0
FD3INFORMATION DISCLOSURE STATEMENTDirector of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language references is discussed in the present specification.
- ☒ 3. The Examiner's attention is directed to co-pending U.S. Patent Application No. 09/260,544, filed March 2, 1999, No. 09/340,236, filed July 1, 1999, and No. 09/661396, filed March 26, 1999 which are directed to related technical subject matter. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination of the present application.

Respectfully submitted,

James A. Oliff
Registration No. 27,075Joel S. Armstrong
Registration No. 36,430JAO:JSA/zmc
Date: January 26, 2001OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--